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Applicant: Tadahiro OHMI et al.
Title: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME
Application No.: 10/725,063
Filing Date: 12/2/2003
Examiner: Pert, Evan T.
Art Unit: 2826

AMENDMENT AND REPLY UNDER 37 C.F.R. 1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Non-Final Office Action dated February 16, 2006, concerning the above-referenced patent application.

Amendments to the Specification begin on page 2 of this document.

Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this document.

Remarks/Arguments begin on page 13 of this document.

Please amend the application as follows: